

FIG.-1



Sheet 2 of 2

Applicant: Uwe W. Hamm

Serial No.: 10/010,135

Title: Process and Device in-situ Decontamination of an EUV-Lithography Device

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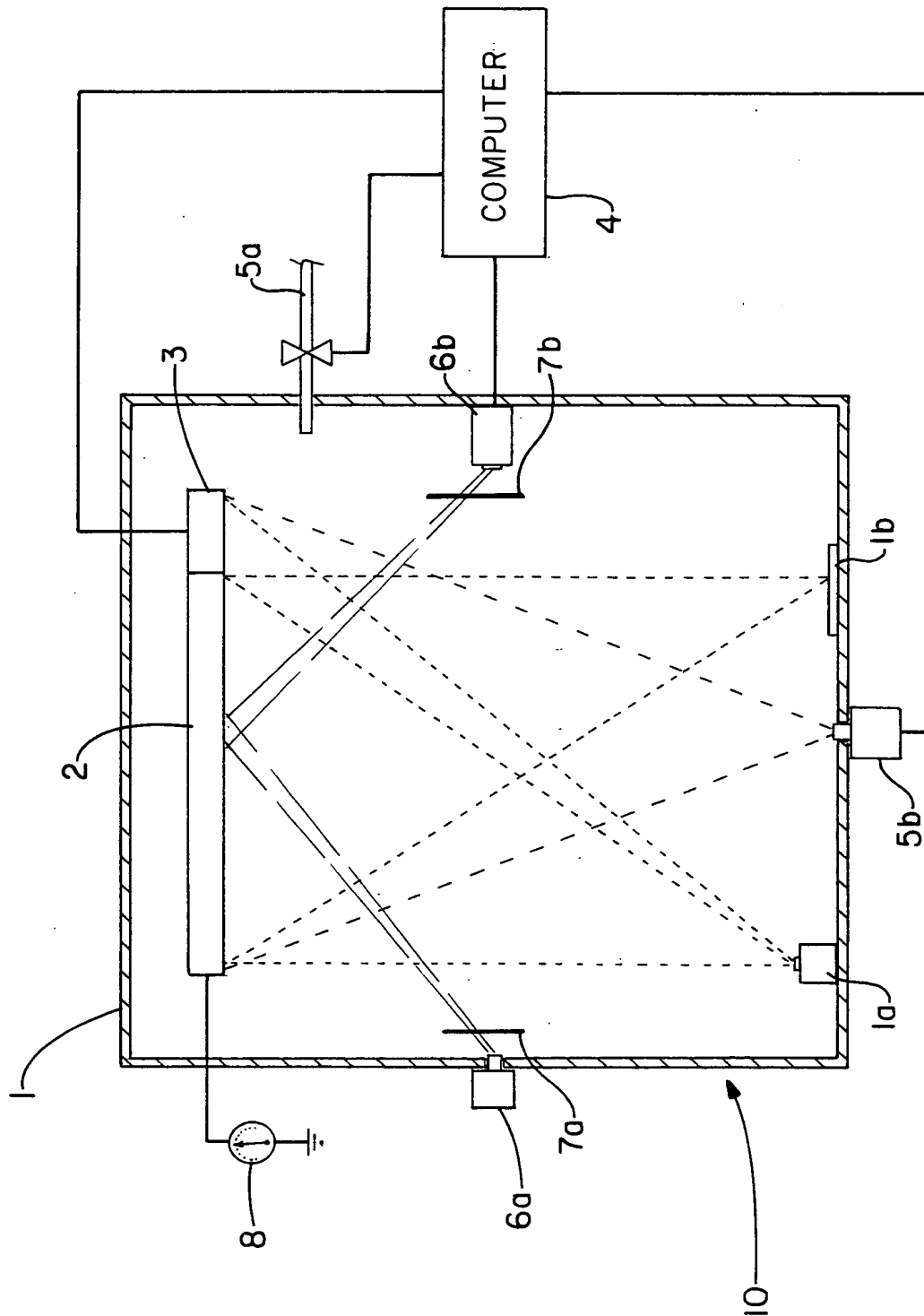


FIG.-2